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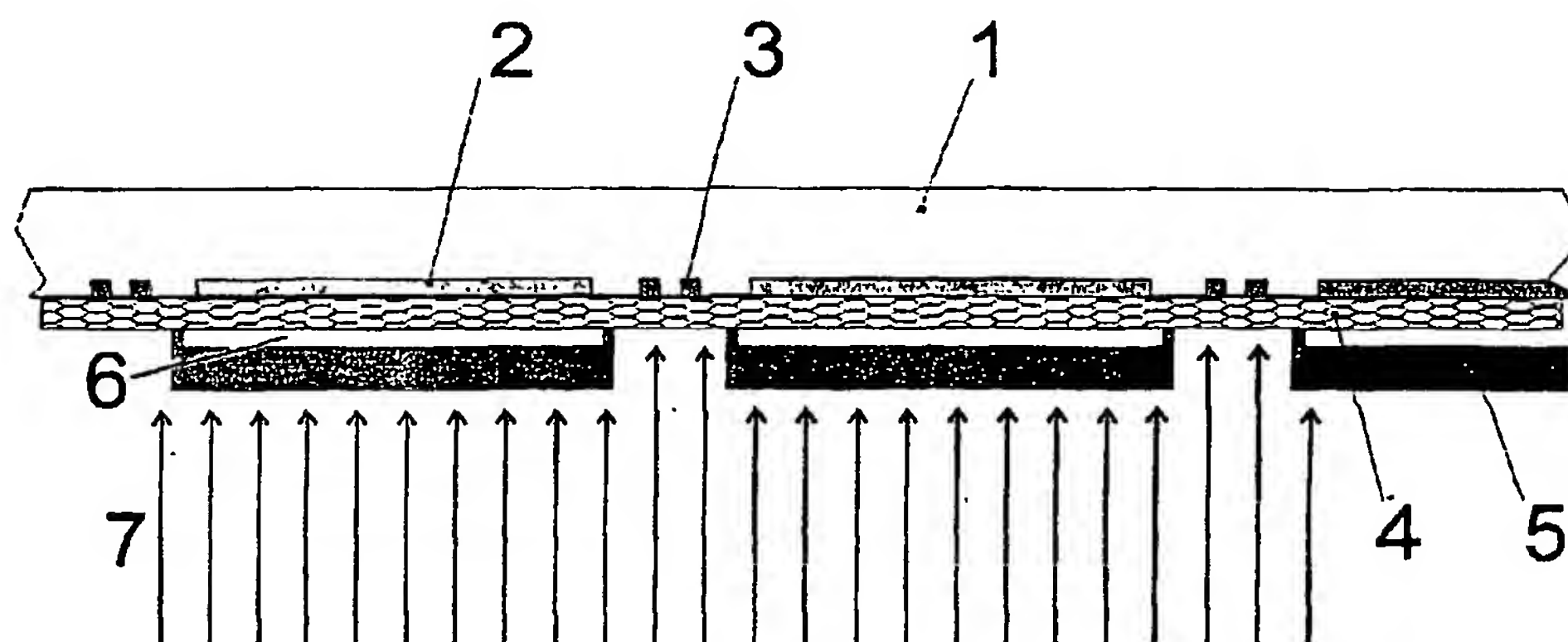
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(54) Title: ION BEAM METHOD FOR REMOVING AN ORGANIC LIGHT EMITTING MATERIAL



(57) Abstract: A method of removing an organic, preferably polymeric, light-emitting material (4) from defined areas of a substrate (1) comprises the steps of arranging a shadow mask (5) to overlie the organic material other than in the defined areas, and applying a beam of ions (7) to the defined areas through the mask. The method is useful in forming organic light-emitting diode arrays.

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